h. An ink jet recording apparatus comprising a plurality of nozzles for discharging a functional liquid, wherein said plurality of nozzles is divided into a plurality of groups the number of which is fewer than the number of said nozzles, and discharge quantity of said functional liquid discharged from said nozzles is controlled group by group.

- The ink jet recording apparatus according to
 claim 1, wherein said functional liquid is ink, and a
 color filter can be manufactured.
 - 3. The ink jet recording apparatus according to claim 1, wherein said functional liquid is a solution of electroluminophor, and an EL element substrate can be manufactured.
 - 4. The ink jet recording apparatus according to claim 1, wherein said functional liquid is an electrically conducting particle dispersion solution, and a substrate comprising a conducting wiring pattern can be

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5. The ink jet recording apparatus according to any one of claims 1 to 4, wherein positions on ink jet head on which said plurality of nozzles is arranged are divided into a plurality of areas, and nozzles belonging to each area are made to belong to a single group.

6. The ink jet recording apparatus according to any one of claims 1 to 5,

wherein said ink jet head on which said
plurality of nozzles is arranged comprises cavities
provided for each of said nozzles, a reservoir
communicating to said cavities and common to said nozzles,
and a supply port for supplying said functional liquid to
said reservoir; and

wherein said plurality of groups comprise at

least a first group comprising nozzles of said plurality

of nozzles positioned close to said supply port, and a

second group comprising nozzles of said plurality of

nozzles positioned far from said supply port.

7. A method for manufacturing a functional liquid applied substrate by an ink jet recording apparatus comprising a plurality of nozzles capable of discharging a functional liquid,

wherein said plurality of nozzles is divided into a plurality of groups the number whereof is fewer than number of said nozzles,

wherein waveform of a signal for controlling discharge of said functional liquid from said nozzles is regulated for each group, and

wherein said functional liquid is discharged in 25 pixels formed on a substrate.

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said reservoir; and

8. The method for manufacturing a functional liquid applied substrate according to claim 7, wherein positions on ink jet head on which said plurality of nozzles is arranged are divided into a plurality of areas, and nozzles belonging to each area are made to belong to a single group.

The method for manufacturing a functional

liquid applied substrate according to claim 7 or 8,

wherein said ink set head on which said

plurality of nozzles is arranged comprises cavities

provided for each of said nozzles, a reservoir

communicating to said cavities and common to said nozzles,
and a supply port for supplying said functional liquid to

wherein said plurality of groups comprise at least a first group comprising nozzles of said plurality of nozzles positioned close to said supply port, and a second group comprising nozzles of said plurality of nozzles positioned far from said supply port.

- 10. A method for manufacturing a device comprising a functional liquid applied substrate manufactured by the method according to any one of claims 7 to 9.
- 11. A method for manufacturing electronic equipment wherein an electro-optical apparatus manufactured by the method according to claim 10 is used.

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12. A device comprising a functional liquid applied substrate manufactured by the method according to any one of claims 7 to 9.